

Video Article

In Situ SIMS and IR Spectroscopy of Well-defined Surfaces Prepared by Soft Landing of Mass-selected Ions

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Abstract

Soft landing of mass-selected ions onto surfaces is a powerful approach for the highly-controlled preparation of materials that are inaccessible using conventional synthesis techniques. Coupling soft landing with *in situ* characterization using secondary ion mass spectrometry (SIMS) and infrared reflection absorption spectroscopy (IRRAS) enables analysis of well-defined surfaces under clean vacuum conditions. The capabilities of three soft-landing instruments constructed in our laboratory are illustrated for the representative system of surface-bound organometallics prepared by soft landing of mass-selected ruthenium tris(bipyridine) dications, $[\text{Ru}(\text{bpy})_3]^{2+}$ (bpy = bipyridine), onto carboxylic acid terminated self-assembled monolayer surfaces on gold (COOH-SAMs). *In situ* time-of-flight (TOF)-SIMS provides insight into the reactivity of the soft-landed ions. In addition, the kinetics of charge reduction, neutralization and desorption occurring on the COOH-SAM both during and after ion soft landing are studied using *in situ* Fourier transform ion cyclotron resonance (FT-ICR)-SIMS measurements. *In situ* IRRAS experiments provide insight into how the structure of organic ligands surrounding metal centers is perturbed through immobilization of organometallic ions on COOH-SAM surfaces by soft landing. Collectively, the three instruments provide complementary information about the chemical composition, reactivity and structure of well-defined species supported on surfaces.

Video Link

The video component of this article can be found at <https://www.jove.com/video/51344/>

Introduction

Soft landing of mass-selected ions onto surfaces remains a subject of current research interest due to the demonstrated capabilities of the technique for the highly-controlled preparation of novel materials¹⁻⁶. Recent efforts have indicated potential future applications of soft landing of mass-selected ions in the preparation of peptide and protein arrays for use in high-throughput biological screening^{7,8}, separation of proteins and conformational enrichment of peptides⁹⁻¹², covalent attachment of peptides to surfaces^{9,10,13,14}, chiral enrichment of organic compounds¹⁵, electrochemical characterization of specific redox-active proteins¹⁶⁻¹⁸, production of thin molecular films^{19,20}, processing of macromolecules such as graphene²¹ and preparation of model catalyst systems through soft landing of ionic clusters²²⁻³⁹, nanoparticles⁴⁰⁻⁴⁸ and organometallic complexes onto support materials^{19,49-56}. The concept of modifying surfaces through soft landing of polyatomic ions was initially proposed by Cooks and co-workers in 1977⁵⁷. In the subsequent years a wide range of instrumental approaches have been developed for the controlled deposition of mass-selected ions from the gas-phase onto surfaces^{1,4,5}. Ions have been produced through processes such as electrospray ionization (ESI)^{10,58,59}, matrix-assisted laser desorption/ionization (MALDI)²¹, electron impact ionization (EI)^{60,61}, pulsed arc discharge⁶², inert gas condensation^{36,63}, magnetron sputtering^{64,65}, and laser vaporization^{25,66,67}. Mass selection of gas-phase ions prior to soft landing has been achieved principally employing quadrupole mass filters^{58,68,69}, magnetic deflection devices⁷⁰, and linear ion trap instruments^{8,59}. A particularly notable advance in ion soft landing methodology occurred recently with the successful implementation of ambient ion soft- and reactive landing by Cooks and co-workers^{71,72}. Using these various ionization and mass-selection techniques, the interactions of hyperthermal (<100 eV) polyatomic ions with surfaces have been studied in order to better understand the factors influencing the efficiency of ion soft landing and the competing processes of reactive and unreactive scattering as well as surface induced dissociation^{4,73-75}.

The preparation of well-defined model catalysts for research purposes has been a particularly fruitful application of soft landing of mass-selected ions^{25,34,35,56,76-81}. In the size range of nanoscale clusters, where physical and chemical behavior does not scale linearly with cluster size, it has been demonstrated that the addition or removal of single atoms to or from clusters may drastically influence their chemical reactivity⁸²⁻⁸⁴. This nanoscale phenomenon, which results from quantum confinement, was demonstrated convincingly by Heiz and co-workers⁸⁵ for a model catalyst consisting of soft landed clusters of eight gold atoms (Au_8) supported on a defect-rich MgO surface. Several additional studies have provided evidence of the size-dependent reactivity of clusters supported on surfaces^{34,77,86,87}. Moreover, high resolution electron microscopy images indicate that clusters containing as few as ten⁸⁸ and fifty five⁸⁹ atoms may be largely responsible for the superior activity of bulk-synthesized gold catalysts supported on iron oxides. Employing soft landing of mass-selected ions, it is possible to prepare stable arrays of size-selected clusters and nanoparticles that do not diffuse and agglomerate into larger structures on the surface of support materials⁹⁰⁻⁹². These previous studies indicate that with continuing development, soft landing of mass-selected clusters and nanoparticles may become a versatile technique for the

creation of highly active heterogeneous catalysts that exploit the emergent behavior of large numbers of identical clusters and nanoparticles in extended arrays on surfaces. These extremely well-defined systems may be used for research purposes to understand how critical parameters such as cluster size, morphology, elemental composition and surface coverage influence catalytic activity, selectivity and durability.

Organometallic complexes that are typically used in the solution-phase as homogeneous catalysts also may be immobilized on surfaces through soft landing of mass-selected ions^{56,80,81}. Attaching ionic metal-ligand complexes to solid supports to produce hybrid organic-inorganic materials is currently an active area of research in the catalysis and surface science communities⁹³. The overall goal is to obtain the high selectivity toward a desired product of solution-phase metal-ligand complexes while facilitating an easier separation of products from catalysts and reactants remaining in solution. In this manner, surface immobilized organometallic complexes reap the benefits of both homogeneous and heterogeneous catalysts. Through selection of an appropriate substrate it is possible to maintain or even enhance the organic ligand environment around the active metal center while also achieving strong surface immobilization⁹⁴. Self-assembled monolayer surfaces (SAMs) on gold may be terminated with a number of different functional groups and are, therefore, ideal systems to investigate the feasibility of tethering organometallic complexes to surfaces through soft landing of mass-selected ions⁹⁵. Furthermore, ionization methods such as atmospheric pressure thermal desorption ionization (APT/DTI) have been demonstrated previously to yield gas-phase mixed-metal inorganic complexes that are not accessible through synthesis in solution⁹⁶. In a similar vein, non-thermal kinetically-limited synthesis and ionization techniques such as magnetron sputtering⁶⁵, gas aggregation⁶³ and laser vaporization⁶⁶ also may be coupled with ion soft landing instrumentation to provide a versatile route to novel inorganic clusters and nanoparticles supported on surfaces.

In order to evolve soft landing of mass-selected ions into a mature technology for the preparation of materials, it is critical that informative analytical methods be coupled with soft landing instrumentation to probe the chemical and physical properties of surfaces before, during and after deposition of ions. To date, a multitude of techniques have been applied for this purpose including secondary ion mass spectrometry (SIMS)^{19,97-100}, temperature programmed desorption and reaction^{50,52}, laser desorption and ionization¹⁰¹, pulsed molecular beam reaction¹⁰², infrared spectroscopy (FTIR and Raman)^{98,103,104}, surface enhanced Raman spectroscopy^{103,105}, cavity ringdown spectroscopy¹⁰⁶, x-ray photoelectron spectroscopy^{35,107}, scanning tunneling microscopy^{33,108-111}, atomic force microscopy¹¹²⁻¹¹⁴, and transmission electron microscopy³⁹. However, to most accurately characterize surfaces prepared or modified by ion soft landing, it is crucial that the analysis be performed *in situ* without exposure of the substrate to the environment in the laboratory. Previous analyses conducted *in situ* have provided insight into phenomena such as the reduction of ionic charge of soft landed ions over time^{37,38,115,116}, the desorption of soft landed ions from surfaces⁵², the efficiency and kinetic energy dependence of ion reactive landing^{14,81}, and the influence of size on the catalytic activity of clusters and nanoparticles deposited onto surfaces¹¹⁷. By way of example, in our laboratory, we have systematically studied the charge reduction kinetics of protonated peptides on the surfaces of different SAMs³. These experiments were performed with a unique soft landing instrument coupled to a Fourier transform ion cyclotron resonance secondary ion mass spectrometer (FT-ICR-SIMS) that enables *in situ* analysis of surfaces both during and after soft landing of ions⁹⁷. To expand upon these analytical capabilities, another instrument was constructed that allows *in situ* characterization of soft landed ions on surfaces using IRRAS¹⁰⁴. This surface-sensitive infrared technique enables bond formation and destruction processes as well as conformational changes in complex ions and surface layers to be monitored in real time both during and after soft landing¹². For instance, using IRRAS it was demonstrated that ion soft landing may be used to covalently immobilize mass-selected peptides on *N*-hydroxysuccinimide ester functionalized SAMs^{13,14}.

Herein, we illustrate the capabilities of three unique custom-built instruments located at the Pacific Northwest National Laboratory that are designed for *in situ* TOF-SIMS, FT-ICR-SIMS, and IRRAS analysis of substrates produced through soft landing of mass-selected ions onto surfaces. As a representative system, we present results for soft landing of mass-selected organometallic ruthenium tris(bipyridine) dications [Ru(bpy)₃]²⁺ onto carboxylic acid terminated SAMs (COOH-SAMs) to prepare immobilized organometallic complexes. It is shown that *in situ* TOF-SIMS offers the advantages of extremely high sensitivity and large overall dynamic range which facilitates identification of low abundance species including reactive intermediates that may only be present for short periods of time on the surfaces. TOF-SIMS also provides insight into how the removal of a ligand from an organometallic ion in the gas-phase, prior to soft landing, influences its efficiency toward immobilization on surfaces and its chemical reactivity towards gaseous molecules. Complementary characterization using *in situ* FT-ICR-SIMS provides insights into the charge reduction, neutralization and desorption kinetics of the doubly charged ions on the surface while *in situ* IRRAS probes the structure of the organic ligands surrounding the charged metal centers, which may influence the electronic properties and reactivity of the immobilized ions. Collectively, we illustrate how soft landing of mass-selected ions combined with *in situ* analysis by SIMS and IRRAS provides insight into the interactions between well-defined species and surfaces which have implications for a broad range of scientific endeavors.

Protocol

1. Preparation of COOH-SAM Surfaces on Gold for Soft Landing of Mass-selected Ions

1. Obtain flat gold substrates on silicon (Si) or mica backing materials. Alternatively, prepare gold films on Si or mica surfaces according to procedures described in the literature^{118,119}. Note: Use surfaces that have the following specifications: 1 cm² or circular and 5 mm in diameter, 525 μm thick Si layer, 50 Å thick Ti adhesion layer, 1,000 Å Au layer.
2. Place fresh gold-on-silicon surfaces into glass scintillation vials and immerse in pure (non-denatured) ethanol.
3. Place scintillation vials containing gold surfaces immersed in ethanol into an ultrasonic cleaner and wash for 20 min to remove any surface debris. Note: Do not ultrasonically wash gold on mica surfaces as this will detach the gold film from the mica backing material.
4. Remove washed gold surfaces from vials and dry with a stream of pure N₂ to prevent the formation of any residual spots from the ethanol.
5. Place the dried gold surfaces face up in an ultraviolet (UV) cleaner and irradiate for 20 min to remove surface organic matter.
6. In glass scintillation vials, prepare 5 ml of 1 mM solutions of 16-mercaptohexadecanoic acid (COOH-SAM) in non-denatured ethanol.
7. Add hydrochloric acid to a final concentration of 1% HCl in ethanol to ensure protonation of the carboxylic acid groups of the molecules.
8. Place the washed, dried and UV-cleaned gold surfaces face up into the COOH-SAM solutions ensuring that the entire gold surface is fully immersed in each vial. Allow the monolayer surfaces on gold to assemble for at least 24 hr in the dark (wrap vials in foil).
9. Remove the surfaces from the COOH-SAM solutions and place in new scintillation vials containing 5 ml of 1% HCl in ethanol. Ultrasonically wash the SAM surfaces for 5 min to remove any physisorbed molecules from the monolayer surface.

10. Remove the washed surfaces from the vials and rinse with several 1 ml aliquots of 1% HCl in ethanol. Dry the COOH-SAM surfaces under a stream of N_2 .
11. Using clean metal forceps and wearing gloves place a SAM surface onto one of three metal sample mounts that are compatible with each soft landing instrument taking care not to touch the front facing gold surface in the process. Ensure that the surface is fixed tightly in place and that there is strong electrical contact between the back side of the surface and the metal sample mount.
12. Employing the load-lock sample introduction capabilities of the soft landing instruments (each is slightly different), ensure that the gate valve separating the sample introduction region of the instrument from the soft landing chamber is closed. Bring the sample introduction chamber up to atmospheric pressure by turning off the turbomolecular vacuum pump and ionization pressure gauge and closing the valve to the foreline mechanical vacuum pump.
13. When the sample introduction chamber reaches atmospheric pressure open the sample door and secure the sample holder firmly to the manipulator (xyz-stage or z-translator) inside of the instrument. Close the door and open the valve to the foreline mechanical vacuum pump. When the sample introduction chamber reaches a pressure of 10^{-3} Torr, turn on the turbomolecular vacuum pump and ionization pressure gauge.
14. When the sample introduction chamber reaches a pressure of 10^{-5} Torr, open the gate valve to the soft landing chamber. Use the magnetic manipulator or xyz-stage to position the SAM surface in line with the ion beam to begin soft landing.

2. Soft Landing of Mass-selected $Ru(bpy)_3^{2+}$ onto COOH-SAM Surfaces

1. Obtain tris(2,2'-bipyridyl)dichloro-ruthenium(II) hexahydrate solid. Dissolve the red crystals in pure methanol to create stock solutions with a concentration of 10^{-3} M. Dilute the stock solutions by a factor of either 10 or 100 with methanol to achieve optimum electrospray ion current of mass-selected $Ru(bpy)_3^{2+}$ $m/z = 285$.
2. Load the diluted solutions into 1 ml glass syringes. Use a syringe pump to infuse the solution through a 360 μm outer diameter 80 μm inner diameter fused silica capillary that is biased between +2 to +3 kV to generate positive ions. Adjust the syringe pump flow rate between 20-40 $\mu l/hr$ to obtain optimum ion current and stability at the surface.
3. Adjust the quadrupole mass-filter to the mass of the $Ru(bpy)_3^{2+}$ ion $m/z = 285$ to prevent soft landing of species other than $Ru(bpy)_3^{2+}$ onto the surface. Using a high-resistance electrometer connected to the substrate through a vacuum electrical feed-through, adjust the voltage settings of the ion optics and radiofrequency ion guides to maximize the ion current and stability of $Ru(bpy)_3^{2+}$ measured at the SAM surface. Allow the experiment to run for a selected period of time to achieve the desired coverage of ions on the surface of the COOH-SAM.
4. Increase the potential gradient in the high-pressure collision quadrupole region of the soft landing instruments to create the harsh conditions that enable gas-phase ligand stripping from the organometallic ion through collision induced dissociation. Note: Examine the schematic diagram of one of the three soft landing instruments, which is also representative of the other two instruments, which is presented in **Figure 1**. The fragmentation of the $Ru(bpy)_3^{2+}$ ion occurs in region 4. Increase the voltage applied to the back plate of the electrodynamic ion funnel to remove one bipyridine ligand from $Ru(bpy)_3^{2+}$ $m/z = 285$ producing gas-phase $Ru(bpy)_2^{2+}$ $m/z = 207$ in region 4 of the instrument⁸¹. Mass select the highly reactive undercoordinated fragment ion using the quadrupole mass filter in region 6 of the instrument and soft land onto COOH-SAM surfaces to examine how the extent of ligation influences the properties of supported organometallic ions.
5. Adjust the surrounding ion optics, including the DC voltages applied to the quadrupole rods as well as the conductance limit to maximize the current of mass-selected $Ru(bpy)_2^{2+}$ fragment ions at the surface.

3. Analysis by *In Situ* TOF-SIMS Before and After Exposure to Reactive Gases

1. Turn off the syringe pump and high voltage to the ESI emitter. Open the gate valve that separates the two regions of the instrument during operation. Use the magnetic manipulator to move the prepared surface from the soft landing chamber to the analysis stage inside the TOF-SIMS part of the instrument.
2. Disengage the manipulator from the sample and retract it fully from the SIMS analysis chamber. Close the gate valve between the soft landing and SIMS parts of the instrument because the TOF-SIMS operates at a much lower pressure than the soft landing region of the instrument.
3. To conduct the TOF-SIMS experiment, load the instrument control file in the software and ensure that the Ga^+ source is producing a sufficiently stable current of primary ions. Note: Employ 15 keV primary gallium ions (Ga^+ , 500 pA, 5 nsec pulse width, 10 kHz repetition rate) to induce desorption of soft landed material from the surfaces. Extract secondary ions ejected from the surface into the mass analyzer, which consists of three separate electrostatic sectors.
4. Acquire x- and y-axis line profiles across the surface to determine the center of the deposited spot of ions on the substrate (typically at the center of the surface and 3 mm in diameter). Position the surface so that the Ga^+ primary ion beam is incident on the center of the deposited spot of ions. Acquire a TOF-SIMS mass spectrum for 5 min.
5. Turn off the primary Ga^+ ion beam and high voltages of the TOF-SIMS. Use the magnetic manipulator to move the sample back into the soft landing part of the instrument. Make sure that the gate valve separating the two chambers is closed before proceeding further.
6. Use a high-vacuum leak valve on the soft landing chamber to introduce a controlled flow of ultra-high purity oxygen (O_2) gas from a cylinder into the instrument. Use the adjustable gate valve in front of the turbomolecular vacuum pump to throttle the pumping speed of the pump to achieve a steady-state pressure of 10^{-4} Torr of O_2 inside the soft landing chamber.
7. Following exposure of the surface to O_2 for 30 min close the leak valve, open the gate valve over the turbomolecular vacuum pump and allow the remaining O_2 to pump away. After the pressure in the chamber has decreased, open the gate valve to the SIMS part of the instrument and use the magnetic manipulator to position the surface on the analysis platform for a second round of TOF-SIMS analysis.
8. After the second TOF-SIMS spectrum is obtained as described in sections 3.3-3.4, open the gate valve and position the surface back in the soft landing chamber for exposure to 10^{-4} Torr of C_2H_4 for 30 min. Perform a SIMS analysis again as described above.

4. Analysis by *In Situ* FT-ICR-SIMS During and After Soft Landing

1. Prepare the SAM surfaces for experiments with the *in situ* FT-ICR-SIMS instrument in a manner similar to that described in section 1 but on circular substrates 5 mm in diameter. Note: Use substrates that are laser cut from a gold coated silicon wafer (5 nm chromium adhesion layer and 100 nm of polycrystalline vapor-deposited gold). Be aware that the most notable difference is that in the FT-ICR-SIMS instrument the surface is positioned inside the bore of a superconducting magnet. The presence of the magnet necessitates that the surfaces be placed at the end of a 5 ft manual z-translator to enable them to be positioned safely and adjustably at the rear plate of the ICR cell.
2. Using the load-lock interface, position a circular SAM surface at the rear trapping plate of the ICR cell located inside of the 6 Tesla magnet. Note: Be aware that this instrument is a specially designed 6-Tesla FT-ICR mass spectrometer configured for studying ion-surface interactions^{97,120}.
3. Operate the ion soft landing portion of the FT-ICR-SIMS instrument in a manner similar to that described in section 2.
4. Use a cesium ion source to create a continuous beam of 8 kV Cs⁺ primary ions to sputter the surface during and after ion soft landing.
5. Utilize the ESI source positioned at 90° toward the main instrument axis to generate ions for soft landing. Focus the ions through a 90° bending quadrupole¹²⁰. Note: Be aware this instrument geometry facilitates simultaneous soft landing of Ru(bpy)₃²⁺ and transmission of the primary Cs⁺ ion beam to the surface thereby enabling the monitoring of the soft landing process both during and after ion deposition.
6. Trap and analyze the secondary ions ejected from the surface using FT-ICR-MS. Note: Employ static SIMS conditions corresponding to a total ion flux of about 10¹⁰ ions/cm² (current 4 nA, duration 80 μsec, spot diameter 4.6 mm, 10 shots per spectrum, ~200 data points) for these experiments that last for about 7 hr. Average each SIMS spectrum over 10 shots corresponding to an acquisition time of ~10 sec.
7. Acquire kinetics data by sampling the SAM surface every 4 min for approximately 7 hr during and after ion deposition.
8. Perform data acquisition and instrument control using an automated modular data control system described in the literature¹²¹.

5. Analysis by *In Situ* IRRAS During and After Soft Landing

1. Prepare the SAM surfaces for experiments with the *in situ* IRRAS instrument in a manner similar to that described in section 1. Note: Be aware that the largest difference with the IRRAS instrument results from the precise positioning of the surface with the z-translator that is necessary to locate the substrate at the focal point of the parabolic mirrors and in line with the beam of ions. Maximize the overlap between the infrared beam and the spot of deposited ions on the surface.
2. Conduct the IRRAS experiments in a grazing-incidence geometry employing an FTIR spectrometer equipped with a liquid nitrogen cooled mercury-cadmium-telluride (MCT) detector.
3. Utilize a gold-coated flat mirror to direct the light exiting the FTIR spectrometer onto a parabolic gold mirror. Reflect the light from the parabolic mirror through a mid-infrared wire grid polarizer and into the vacuum chamber through a viewport.
4. Direct the infrared light from the spectrometer onto the COOH-SAM surface positioned inside the vacuum chamber. Note: The vacuum chamber is held at a pressure of 10⁻⁵ Torr during ion soft landing.
5. Position the reflective SAM on gold surface inside the vacuum chamber at the focal point of the first parabolic mirror using the motor-driven z-translator.
6. Reflect the IR light entering the vacuum chamber from the surface of the SAM and out of the chamber through a second viewport. Use a second parabolic gold mirror to focus the reflected light from the surface onto an MCT detector.
7. Purge the pathway of the IR beam outside of the vacuum chamber with N₂.
8. Acquire spectra at set intervals during the deposition.

Representative Results

1. Investigating the Reactivity of Ru(bpy)₃²⁺ on COOH-SAMs Using *In Situ* TOF-SIMS

Soft landing of mass-selected organometallic ions onto functionalized SAMs is first illustrated using *in situ* TOF-SIMS to provide maximum sensitivity toward detection of adducts formed between the deposited ions and the individual molecules in the monolayers as well as any products of chemical reactions following exposure of the surfaces to reactive gases. The doubly charged Ru(bpy)₃²⁺ ion originates from dissolution and dissociation of solid-phase tris(2,2'-bipyridyl)dichlororuthenium(II) hexahydrate crystals in methanol. The Ru(bpy)₃²⁺ *m/z* = 285 dication selected for the representative soft landing experiments described herein is the most abundant ion generated from electrospray ionization of the solution. Undercoordinated Ru(bpy)₂²⁺ ions are prepared by fragmentation of one bipyridine ligand from each fully ligated Ru(bpy)₃²⁺ ion. This is induced by gas-phase collision-induced-dissociation in the first quadrupole region of the soft landing instrument shown schematically in **Figure 1**. An ion current of around 100 pA and 60 pA is directed at the COOH-SAM surfaces for 30 and 45 min for Ru(bpy)₃²⁺ and Ru(bpy)₂²⁺, respectively, corresponding to a total delivery of 5 × 10¹¹ mass-selected ions to a circular spot approximately 3 mm in diameter. The kinetic energy of the ions approaching the surface is determined by adjusting the potentials applied to the second collision quadrupole (see **Figure 1**) and the surface. The kinetic energy is set at around 10 eV per charge for all of the soft landing experiments conducted using the *in situ* TOF-SIMS apparatus.

Following soft landing of 5 × 10¹¹ intact Ru(bpy)₃²⁺ ions onto the surface of the COOH-SAM, a number of new peaks that are not present prior to deposition become prominent in the TOF-SIMS spectra. Isotopic envelopes corresponding to intact doubly charged Ru(bpy)₃²⁺ *m/z* = 285 and singly charged Ru(bpy)₃⁺ *m/z* = 570 are observed following soft landing of Ru(bpy)₃²⁺ onto the COOH-SAM surface. The relative abundance of these species suggests that reduction of the ionic charge of Ru(bpy)₃²⁺ to Ru(bpy)₃⁺ takes place rapidly on the surface of the COOH-SAM. Another isotopic envelope is present at *m/z* = 414 which corresponds to the fragment Ru(bpy)₂⁺. This singly charged ion, which results from loss of one bipyridine ligand from singly charged Ru(bpy)₃⁺, is likely formed through dissociation of Ru(bpy)₃⁺ during analysis by TOF-SIMS. In contrast, the TOF-SIMS spectrum obtained following soft landing of the fragment Ru(bpy)₂²⁺ lacks any of the characteristic peaks related to the intact complex (*i.e.* Ru(bpy)₃²⁺ or Ru(bpy)₃⁺). Most importantly, a peak corresponding to a Ru(bpy)₂-thiol⁺ adduct at *m/z* = 700 is observed

which indicates very strong binding between the undercoordinated ion and the monolayer surface. The peaks corresponding to this species are featured prominently in **Figure 2a**.

After soft landing, the COOH-SAM surfaces are exposed to controlled pressures of either O₂ or C₂H₄ in the deposition region of the instrument to examine the chemical reactivity of the immobilized organometallic complexes. Following gas exposure, the surfaces are analyzed again by *in situ* TOF-SIMS. Presented in **Figures 2b** and **2c** are the *in situ* TOF-SIMS spectra obtained directly following exposure of the COOH-SAM surfaces containing soft landed Ru(bpy)₃²⁺ and Ru(bpy)₂²⁺ ions to O₂ and C₂H₄. As discussed in the preceding paragraph, following soft landing of Ru(bpy)_{2/3}²⁺ onto COOH-SAM surfaces an isotopic distribution corresponding to an electrostatic adduct formed between the ions and the surface molecules is observed. After exposure of the surface to 10⁻⁴ Torr of O₂ for 30 min the TOF-SIMS spectra indicate that there is an obvious reduction in the abundance of the adduct peak at *m/z* = 700 accompanied by a concomitant increase in the abundance of two new isotopic envelopes centered at *m/z* = 716.2 and 732.2. These peaks are consistent with the addition of atomic (O) and molecular (O₂) oxygen to the organometallic surface adduct, respectively. Moreover, this adduct appears to be oxidized with close to 50% conversion efficiency. After exposure to O₂ and analysis by *in situ* TOF-SIMS the surfaces are positioned back into the soft landing region of the instrument and exposed to 10⁻⁴ Torr of C₂H₄ for 30 min. Following the second gas exposure the surface is transferred again to the SIMS region of the instrument for another round of analysis. Inspection of the TOF-SIMS spectrum following exposure to C₂H₄ indicates a decrease in the relative abundance of the singly oxidized organometallic adduct at *m/z* = 716. This observation is consistent with deoxygenation of the immobilized organometallic complex upon exposure to C₂H₄. This is hypothesized to result in the formation of the oxidized hydrocarbon (C₂H₄O), which is released to the gas-phase. Therefore, through a combination of soft landing of mass selected ions and analysis by *in-situ* TOF-SIMS it is possible to selectively isolate organometallic compounds on surfaces and examine their reactivity towards gaseous molecules. In addition, the behavior of undercoordinated ions that are not accessible in solution may be examined. A scheme describing what is achieved for this representative system through the combination of ion soft landing and analysis by *in-situ* TOF-SIMS is presented in **Figure 3**.

2. Studying the Charge Retention of Ru(bpy)₃²⁺ on COOH-SAMs Using *In Situ* FT-ICR-SIMS

Soft-landing of mass-selected ions is also conducted employing a second instrument that enables analysis of the surfaces by *in situ* FT-ICR-SIMS. This complementary approach, which enables SIMS analysis of the surfaces both during and after soft landing of ions, is capable of providing insight into the kinetics of charge reduction and neutralization as well as the desorption of ions deposited on surfaces¹¹⁵. It is a particularly powerful technique because the relative abundance of different ionic charge states on the surface may be monitored over periods of several hours. Representative results for Ru(bpy)₃²⁺ soft landed onto a COOH-SAM surface are presented in **Figure 4**. During soft landing the doubly charged Ru(bpy)₃²⁺ ion exhibits a linear increase in abundance on the COOH-SAM surface. The measured abundance reaches a maximum at the end of soft landing and is followed by an extended plateau on the COOH-SAM surface. This indicates that the COOH-SAM surface is particularly effective at preserving the ionic charge state of the intact ions following soft landing. The singly charged Ru(bpy)₃⁺ ion also exhibits a linear increase in abundance with respect to time during soft landing. At the end of soft landing, however, the singly charged ion decreases in abundance. The abundance of the singly charged fragment ion resulting from loss of one bipyridine ligand from Ru(bpy)₃⁺ forming Ru(bpy)₂⁺ is also shown in **Figure 4**. This ion displays a linear increase in abundance during soft landing followed by a decline in abundance on the COOH-SAM after the end of deposition. Because the binding energy of ions to the surface increases with the charge state, it is reasonable to assume that singly charged ions undergo more facile desorption from the surface as compared to the doubly charged ions, which is consistent with the faster loss of singly charged ions observed in this study. Soft landing coupled with *in situ* FT-ICR-SIMS is, therefore, a powerful technique for investigating processes such as the reduction of charge, neutralization and desorption of ions deposited on surfaces.

3. Probing the Structural Features of Ru(bpy)₃²⁺ on COOH-SAMs Employing *In Situ* IRRAS

The third instrument used for characterizing soft-landed ions is able to obtain vibrational spectra of the Ru(bpy)₃²⁺ ions on the COOH-SAMs in addition to detecting changes to the chemically-modified surface due to ion-surface interactions. This instrument is particularly powerful because it measures changes in the vibrational features of the surface both during and after soft landing. Therefore, a wealth of structural information regarding soft landed ions may be obtained using this instrument, provided that sub-monolayer levels of ions are deposited and that the transition dipole moments of the soft landed ions are aligned favorably and possess sufficient intensity to interact with the polarized IR photons incident on the surface.

The infrared spectrum obtained following soft landing of 5 x 10¹² Ru(bpy)₃²⁺ ions onto the COOH-SAM surface is presented in **Figure 5**. We note that because the IR spectrum of the bare COOH-SAM was used as the background spectrum, the features observed following ion deposition originate solely from the vibrational modes of the soft-landed ions. Nine vibrational features are noted with an asterisk in the IR spectrum as unique spectroscopic signatures of Ru(bpy)₃²⁺. These IR features are in good agreement with previously assigned values for this organometallic ion^{122,123}. Out of the observed vibrational frequencies, the C-C stretching (1,606; 1,570; 1,042 cm⁻¹) and C-C-H bending (1,466; 1,450; 1,420; 1,257; 1,186 cm⁻¹) bands as well as the IR signature of a C-N stretch at 1,549 cm⁻¹ are assigned as unique features of the molecular structure of Ru(bpy)₃²⁺. When conducting ion soft landing experiments, it is desirable to characterize the surface using spectroscopy techniques in order to confirm the identity of the species deposited and to gain insights into possible changes in structure that may result from ion-surface interactions. To this end, the *in situ* IRRAS soft landing instrument proves to be a valuable resource that contributes to the broader information gathered about the system of interest using TOF and FT-ICR-SIMS.

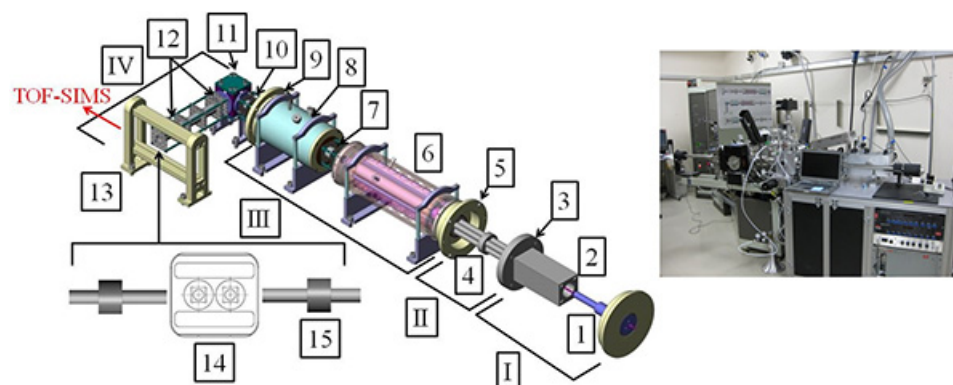


Figure 1. Schematic illustration of the ion deposition instrument coupled to the TOF-SIMS: I, ion funnel region (7×10^{-1} Torr). II, collision quadrupole region (1×10^{-1} Torr). III, mass selection and focusing region (2×10^{-4} Torr). IV, deposition region (1×10^{-6} Torr). (1) heated capillary, (2) electrodynamic ion funnel, (3) first conductance limit, (4) first collision quadrupole, (5) second conductance limit, (6) resolving quadrupole, (7) 2 focusing lenses, (8) second collision quadrupole, (9) third conductance limit, (10) Einzel lens, (11) quadrupole bender, (12) two Einzel lenses, (13) target platform, (14) surface mount, (15) magnetic translators. This figure has been modified from [Analytical Chemistry 2010, **82**(13), 5718-5727]. [Click here to view larger image.](#)

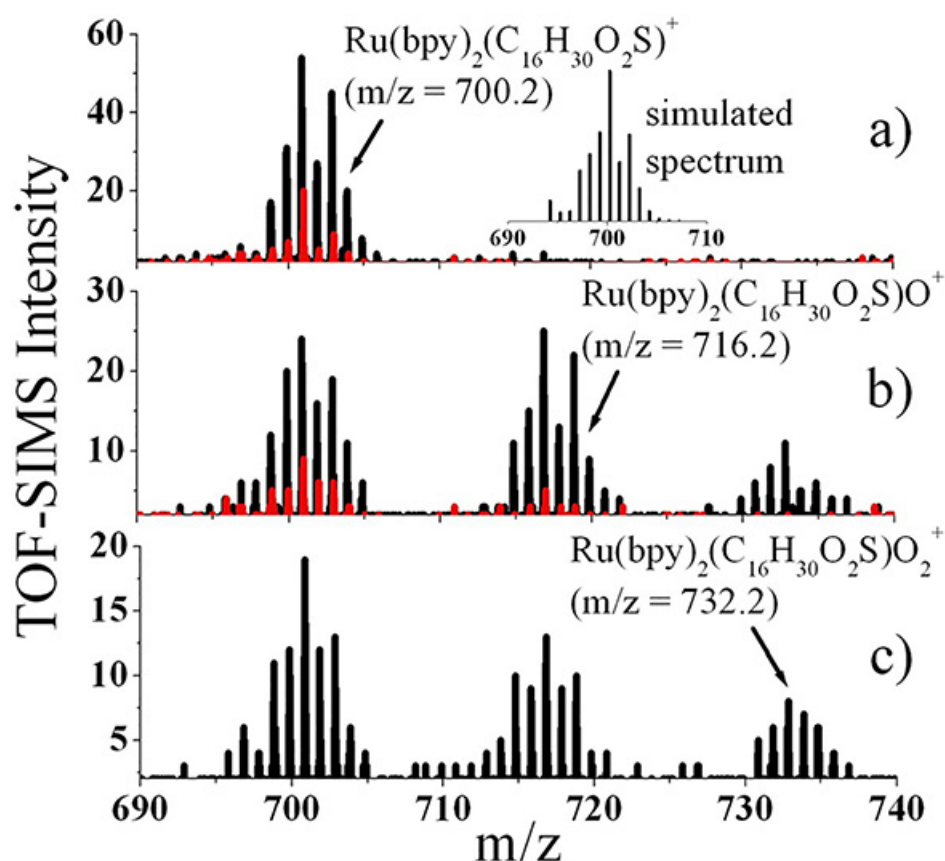


Figure 2. TOF-SIMS spectra (m/z 690-740). Obtained **a)** after mass-selected deposition of $\text{Ru}(\text{bpy})_2^{2+}$ (black) and $\text{Ru}(\text{bpy})_3^{3+}$ (red) onto the surface of COOH-SAM, **b)** after exposure to O_2 and **c)** after exposure to C_2H_4 . This figure has been modified from [Chemistry-A European Journal 2010, **16**(48), 14433-14438]. [Click here to view larger image.](#)

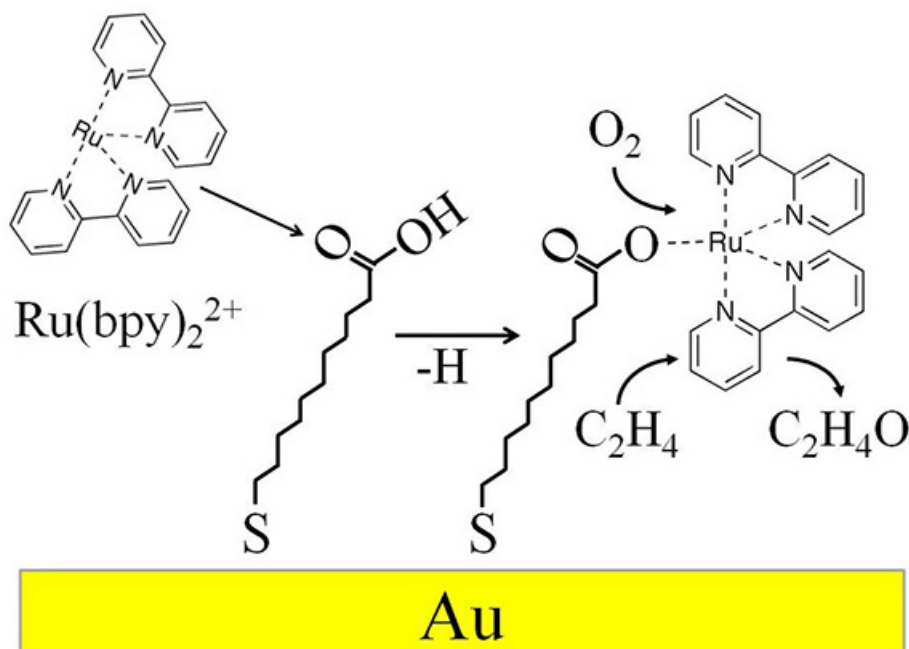


Figure 3. Schematic representation of the immobilization of $\text{Ru}(\text{bpy})_2^{2+}$ on COOH-SAM surfaces through gas-phase ligand stripping and soft landing of mass-selected ions. This figure has been modified from [Chemistry-A European Journal 2010, 16(48), 14433-14438]. [Click here to view larger image.](#)

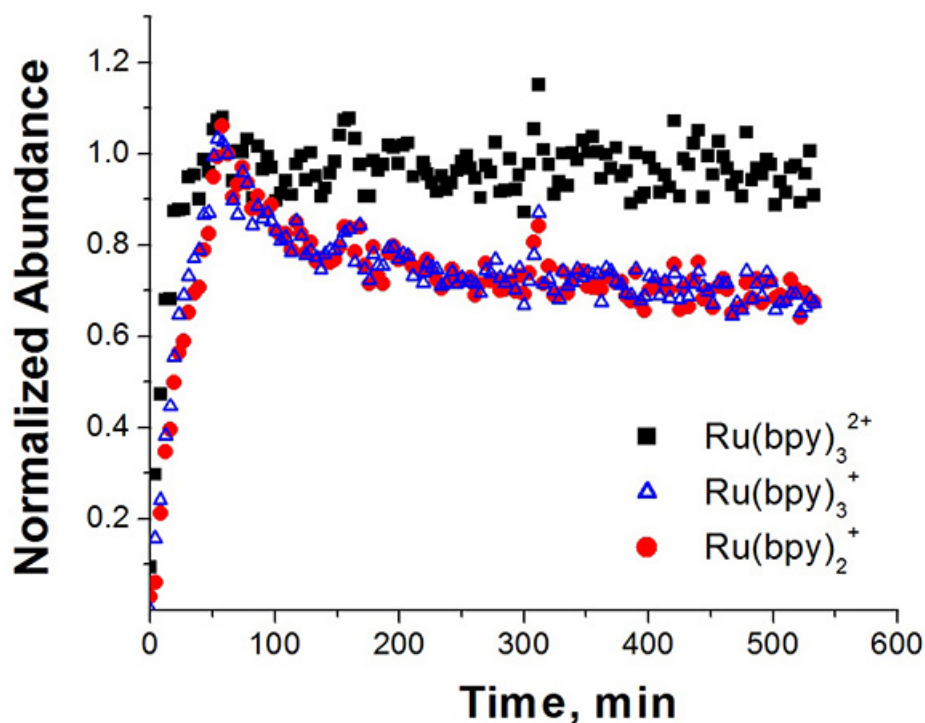


Figure 4. FT-ICR SIMS kinetic plots. Obtained for $\text{Ru}(\text{bpy})_3^{2+}$ ($m/z = 285$, black squares), $\text{Ru}(\text{bpy})_3^+$ ($m/z = 570$, blue triangles) and $\text{Ru}(\text{bpy})_2^+$ ($m/z = 414$, red dots) following soft landing of $\text{Ru}(\text{bpy})_3^{2+}$ onto a COOH-SAM surface. [Click here to view larger image.](#)

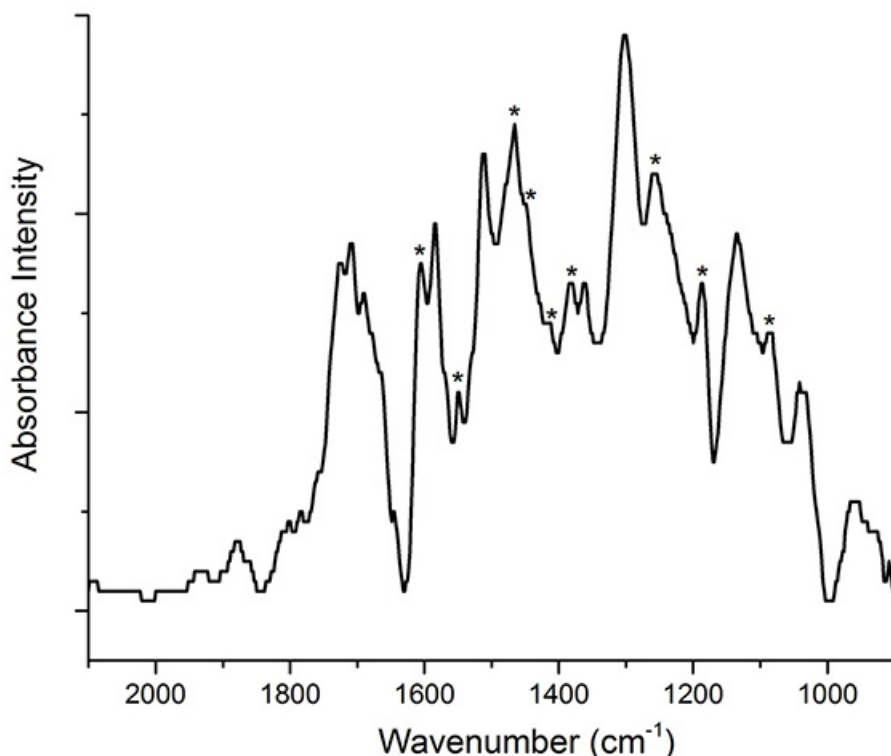


Figure 5. IRRAS spectrum of $\sim 5 \times 10^{12}$ $\text{Ru}(\text{bpy})_3^{2+}$ ions soft landed on the surface of a COOH-SAM. The major vibrational features assigned to $\text{Ru}(\text{bpy})_3^{2+}$ are denoted by an asterisk. [Click here to view larger image.](#)

Discussion

Soft landing of mass-selected ions is generally conducted employing unique custom-built instrumentation that exists in several laboratories around the world that are specially equipped for these experiments. Modifications are constantly being made to these instruments to facilitate the ionization of a wider array of compounds, to achieve larger ion currents and shorter deposition times, to multiplex soft landing and thereby achieve simultaneous deposition of several species at different locations on the surface, and to allow more accurate selection of ions by both mass-to-charge ratio and ion mobility prior to deposition. In a similar fashion, a constantly changing lineup of characterization techniques is being coupled with ion soft landing instrumentation to enable *in situ* analysis of deposited material. Despite these differences between individual instruments, one of the most common problems encountered in soft landing experiments is the inability to route a sufficiently strong and stable beam of mass-selected ions from the source region of the instrument to the surface. This may result from poor ionization efficiency at the source, improperly adjusted voltages that steer the ions through the instrument, and poor electrical contact between the surface and the electrometer used to measure the current of soft landed ions. In such troublesome situations, the ion beam may be routed through the instrument manually by first maximizing the ion current measured at the earliest stage of the instrument and then systematically optimizing the current measured on each subsequent optic along the total beam path. Common problems encountered during *in situ* analysis of soft landed materials include large background signals from contaminant molecules such as adventitious hydrocarbons. For this reason it is critical that the surfaces are prepared carefully and reproducibly prior to each soft landing experiment.

Soft landing of mass-selected ions may be used to prepare extremely well-defined surfaces for subsequent analysis by *in situ* SIMS and IRRAS spectroscopy as well as a whole host of additional *ex situ* microscopy and spectroscopy techniques⁶. Mass selection offers precise control over the molecular composition and ionic charge state of soft landed materials. Furthermore, unprecedented surface cleanliness is obtainable with ion soft landing because common contaminants such as neutral molecules, counterions and solvent that are present in solution are removed from the ion beam prior to deposition so that only the mass-selected ions are delivered to the substrate under sterile vacuum conditions. The coverage of ions on the surface may be carefully controlled by monitoring the current of soft landed ions and varying the length of the deposition accordingly. The kinetic energy of the ions may be reduced to achieve soft landing conditions or increased to promote reactive landing through covalent bond formation¹⁴ or "pinning" of ions into the surface²².

In situ TOF-SIMS, compared to the other FT-ICR-SIMS technique, is generally characterized by greater sensitivity, larger dynamic range, less fragmentation of sputtered secondary ions, and fewer reactions of sputtered material in the plume of secondary ions. The larger dynamic range and higher sensitivity of TOF-SIMS enable detection of low-abundance species produced by ion soft landing onto surfaces. Using *in situ* TOF-SIMS it is possible to identify adducts that are formed between soft landed ions and individual molecules on monolayer surfaces. In addition, *in situ* TOF-SIMS illustrates that undercoordinated ions prepared by gas-phase collision induced dissociation may be more active towards surface immobilization than fully ligated ions. It should be noted that these undercoordinated metal ions do not exist in the solution phase and, therefore, represent novel species prepared using the capabilities of the soft landing instrumentation and identified using TOF-SIMS. Another powerful capability of the *in situ* TOF-SIMS instrument is the ability to expose the surfaces to controlled pressures of reactive gases and subsequently analyze any changes in surface composition without breaking vacuum.

In situ FT-ICR-SIMS, while generally less sensitive and prone to somewhat higher yields of fragment ions and products of gas-phase ion-molecule reactions than TOF-SIMS, offers the additional capability of being able to monitor the composition of the surface both during and after soft landing over a period of several hours. This information is critical to understanding processes such as reduction of charge and desorption of ions from the surface. For example, this instrument has been used previously to monitor redox chemistry taking place between two different ions soft landed onto the same SAMs⁸⁰. In addition, the charge reduction and desorption kinetics of multiply protonated peptide ions also have been studied using this instrument and the data was applied to produce a kinetic model describing the evolution of different charged species on the surfaces of SAMs over time.

Employing *in situ* IRRAS, structural information about soft landed ions on surfaces may be obtained to verify that the ions retain their integrity during the deposition process. This is achieved by comparing the measured infrared spectra of ions on surfaces with previous spectra obtained by infrared spectroscopy in the gas phase and solution phase as well as IR spectra calculated using theoretical modeling. By comparing this known structural information with the measured vibrational features of the deposited samples, changes to the gas-phase structures may be identified. In addition, insight into ion-surface interactions may be ascertained from the observation of vibrational features that increase in intensity during the course of soft landing. Such an observation is consistent with the formation of new bonds at the surface. In a similar vein, vibrational features that decrease during the soft landing process may be indicative of bond-breaking reactions.

The controlled preparation of high-purity thin films on surfaces is necessary for a variety of applications in materials science and microfabrication¹²⁴. Currently, a popular method for the preparation of thin organic films and hybrid organic-inorganic interfaces is molecular layer deposition (MLD) which depends on self-limiting interfacial reactions occurring between molecules and surfaces^{125,126}. MLD enables a great deal of control over the deposition process and, therefore, generally produces higher-quality films on surfaces than solution-phase methods¹²⁷. Nevertheless, despite the widespread commercial use of MLD, this technique is known to suffer from several key limitations which have been reviewed in a recent publication¹²⁸. Most importantly, due to the fact that MLD relies on deposition of neutral molecules from the gas phase it is limited to thermally stable reactants that have enough vapor pressure to yield efficient deposition rates without causing thermal degradation of the compound. Another limitation of MLD stems from the fact that the reactivity of molecules with solid supports may be significantly reduced in the absence of solvent. Soft landing of mass-selected ions onto surfaces overcomes these major limitations of MLD. First, gentle ionization employing electrospray may produce ions of large thermally labile molecules that have very low volatility without inducing fragmentation or degradation. In addition, non-thermal ion sources may be used to generate a range of homogeneous or heterogeneous clusters and nanoparticles that are not susceptible to thermal volatilization. Moreover, ions may be accelerated prior to deposition to the kinetic energy necessary to overcome any potential barriers associated with interfacial reactions.

Soft landing of mass-selected ions is particularly well suited to the controlled immobilization of complex molecules, clusters, and nanoparticles on substrates. However, commercial-scale preparation of materials with this technique is limited due to the fact that the typical ion currents obtained with ESI are several orders of magnitude lower than those currently utilized in existing micro- and nanofabrication methods. The continued development of bright high transmission ESI sources¹²⁹⁻¹³¹, high power and fast repetition rate pulsed laser sources^{25,132} and continuous sources based on DC and RF magnetron sputtering^{43,65,133-135} is a crucial prerequisite for transitioning soft landing from a powerful tool in fundamental science to a practical approach for microfabrication. In the future, combining soft landing with ion mobility separation¹¹³ will facilitate accurate control of both the primary and the secondary structure of complex ions, which is important both for practical applications as well as for investigating the effect of different surfaces on the secondary structure of immobilized ions. Furthermore, the unique capabilities of soft landing instrumentation will be used to manipulate molecules in the gas-phase, either through collisional fragmentation or ion-molecule reactions, to generate novel species that are not obtainable through synthesis in solution.

Disclosures

The authors have nothing to disclose.

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